

# U.S. UTILITY Patent Application

PATENT NUMBER and  
ISSUE DATE

APPL NO/M 10034497	FILING DATE 12/28/2001	CLASS 438	SUBCLASS	GAU 2814	EXAMINER QUACH, T
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\*\*CONTINUING DATA VERIFIED:

FOREIGN APPLICATIONS VERIFIED:  
REPUBLIC OF KOREA 2001-54511 09/05/2001

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PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO	
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		CU-2756 VE	
Verified and Acknowledged Examiners's initials			
TITLE : Method of forming a contact for a semiconductor device			

U.S. DEPT. OF COMM. / PAT. & TM. PTO-436 (Rev. 12-94)

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	Print Claim for 0.6
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheets Drawg.	Figs. Drawg. Print Fig.
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		<b>Application Examiner</b>	
		<b>PREPARED FOR ISSUE</b>	
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